

L Number	Hits	Search Text	DB	Time stamp
1	1	09/887449	USPAT	2004/07/27 12:26
2	1	("5854115").PN.	USPAT	2004/07/27 12:26
3	1	(("5854115").PN.) and (semiconductor or device or lower or work or function or nitrification or conductive or metal or silicide or gate or inhibited or interconnect or selected or interconnecting or tungsten or cobalt or nickel or nitrided or nitrogen or implanting or ions or tantalum)	USPAT	2004/07/27 12:42
4	1	("5960319").PN.	USPAT	2004/07/27 12:43
5	1	(("5960319").PN.) and (semiconductor or device or lower or work or function or nitrification or conductive or metal or silicide or gate or inhibited or interconnect or selected or interconnecting or tungsten or cobalt or nickel or nitrided or nitrogen or implanting or ions or tantalum)	USPAT	2004/07/27 12:43
6	1	("6013546").PN.	USPAT	2004/07/27 12:43
7	1	(("6013546").PN.) and (semiconductor or device or lower or work or function or nitrification or conductive or metal or silicide or gate or inhibited or interconnect or selected or interconnecting or tungsten or cobalt or nickel or nitrided or nitrogen or implanting or ions or tantalum)	USPAT	2004/07/27 12:43
8	38	257/454	USPAT	2004/07/27 12:43
9	50	257/455	USPAT	2004/07/27 12:44
10	33	257/456	USPAT	2004/07/27 12:44
11	864	257/288	USPAT	2004/07/27 12:44
12	435	257/649	USPAT	2004/07/27 12:44
13	844	257/510	USPAT	2004/07/27 12:44
14	110	257/914	USPAT	2004/07/27 12:44